

Abstract

One aspect of the present invention is an aluminum substrate for magnetic recording medium comprising an aluminum sheet and a coating film formed on the surface of the aluminum sheet, wherein the coating film is a multilayer film including an anodized film and a SiO₂ film in this order from the side of the aluminum sheet, the anodized film has a thickness of 7 μm to 45 μm , and the SiO₂ film has a thickness of 1 μm to 5 μm .